

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Application of: ) Group Art Unit: 1792  
Yonhua Tzeng )  
Serial No.: 10/772,740 ) Examiner: Stouffer, Kelly M.  
Filed: February 5, 2004 )  
For: **METHOD OF PLASMA**  
**ENHANCED CHEMICAL VAPOR**  
**DEPOSITION OF DIAMOND**  
**USING METHANOL-BASED**  
**SOLUTIONS** ) **AMENDMENT AND RESPONSE TO**  
 ) **OFFICE ACTION MAILED**  
 ) **May 12, 2008**  
 )  
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## AMENDMENTS

Sir:

Please amend the subject application as follows:

**Amendments to the Claims** are reflected in the listing of claims, which begins on page 2 of this paper.

**Remarks/Arguments** begin on page 7 of this paper.